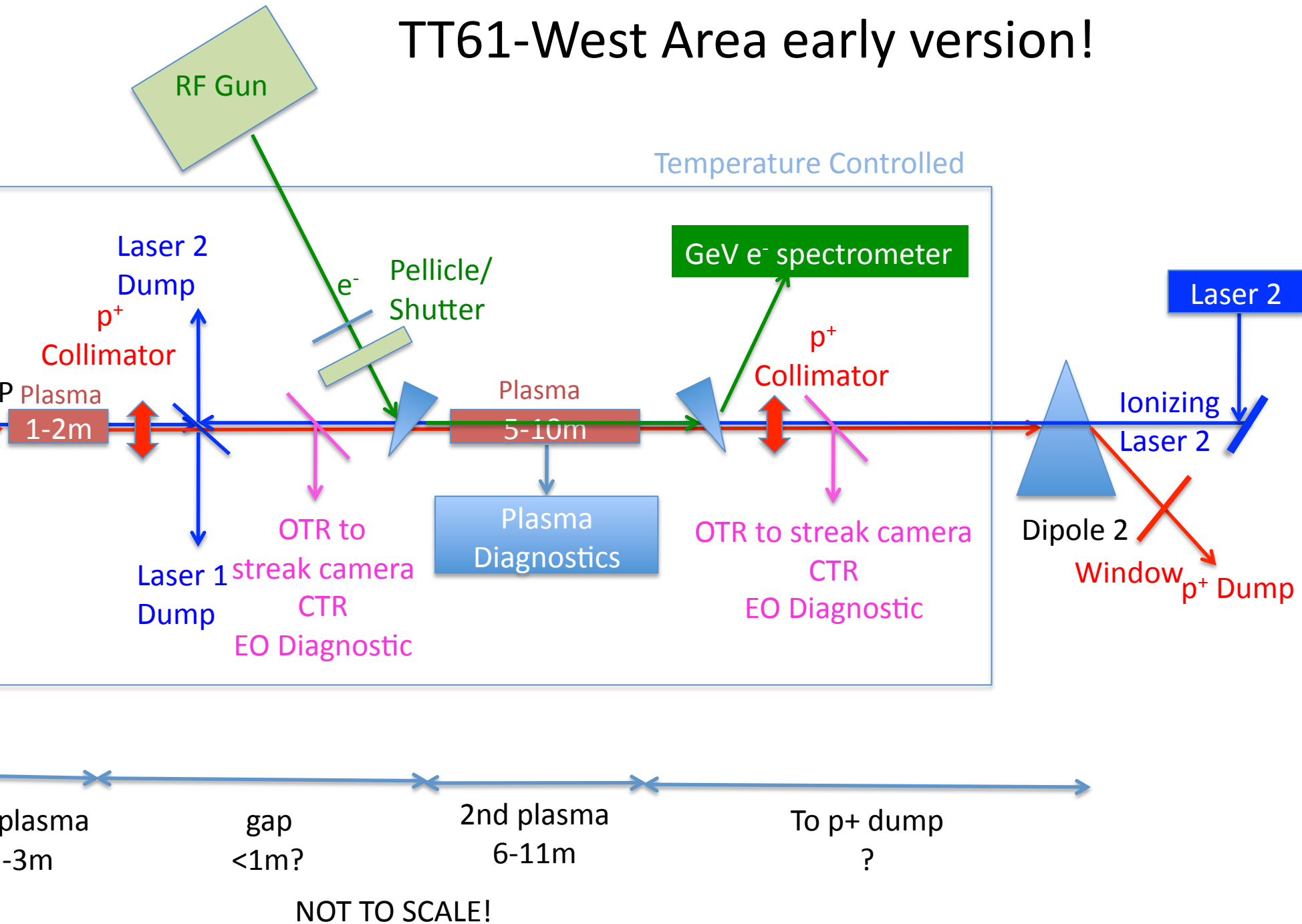


of the nominal design

P. Muggli

ng collaboration discussions

TT61-West Area early version!



- Need long en (>10m?)
- Entire system (Dipole 2) unc
- Length of fin
- Need quadru
- What distanc
- e^- injection a
- Is the laser d
- Can the p^+ b

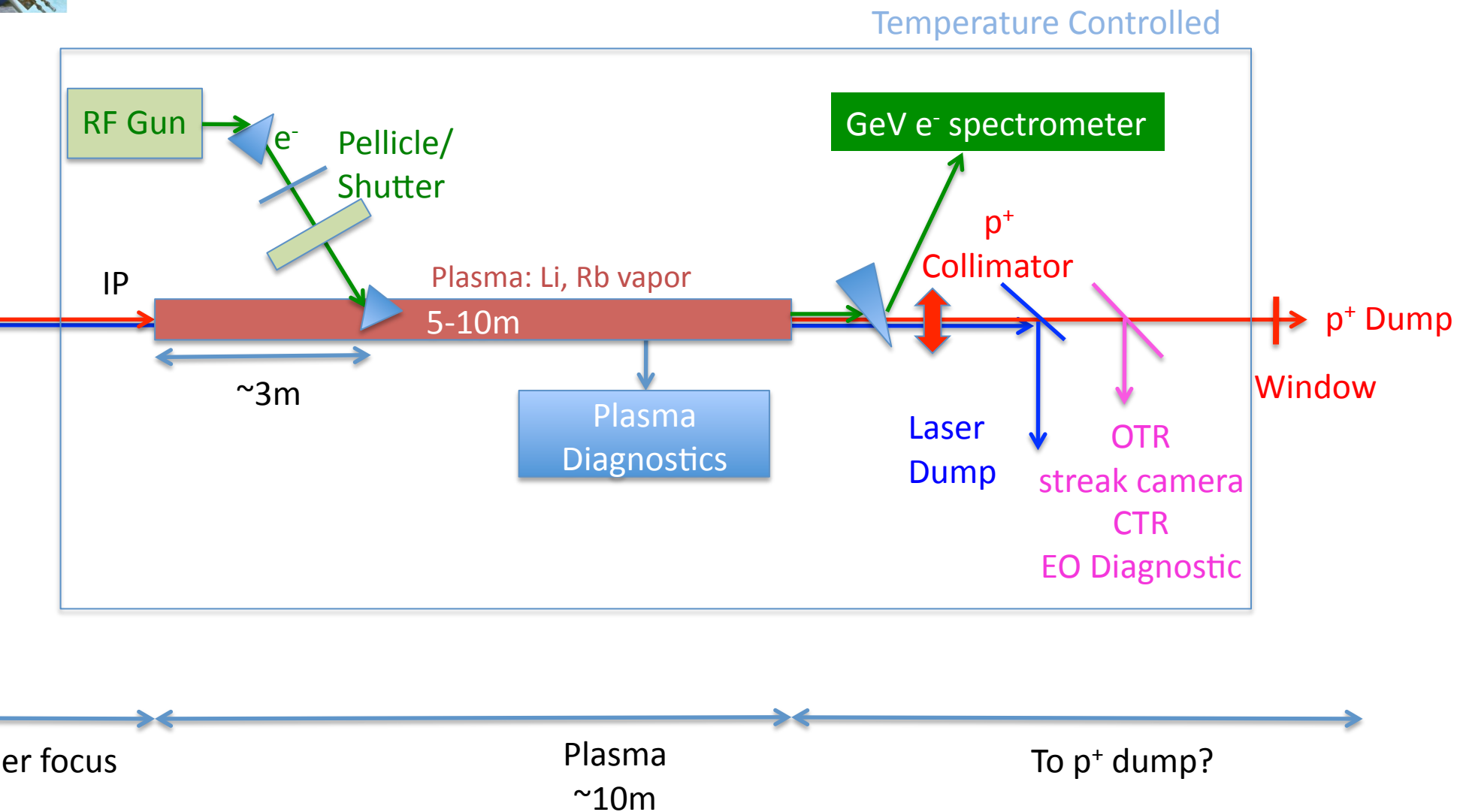
Critical iss

Plasma de
Resonant



A. Petrenko

TT61-West Area version!

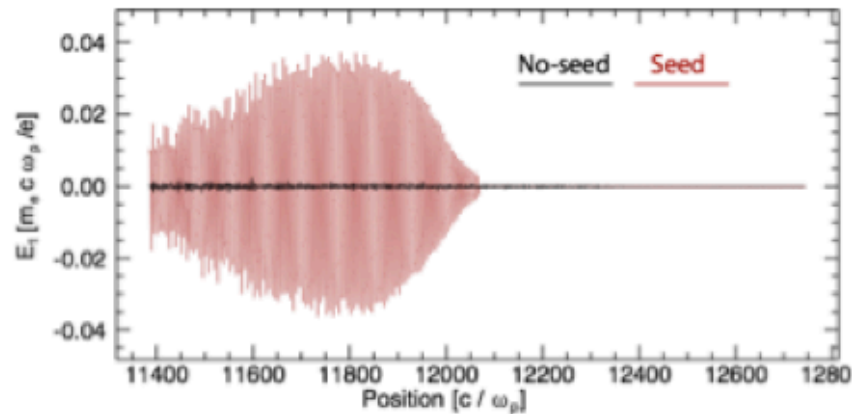


NOT TO SCALE!

- Need long en
- Entire system
- Length of fin
- Need quadru
- e^- injection a
- Energy in the
- Spectromete
- particle dete
- Is the laser d
- Can the p^+ b
- (alternative t
- p^+ collimatio



Laser seeding of SMI in OSIRIS



Equation for the laser envelope Ponderomotive guiding center

Equation for laser pulse envelope:

$$\partial_{\tau} a = \frac{1}{2i\omega_0} \left[\left(1 + \frac{1}{i\omega_0} \frac{\partial}{\partial \xi} \right) + \nabla_{\perp}^2 \right] a$$

$\tau=t$ laser frequency $\xi=x-ct$ laser envelope

D. Gordon, W. Mori, T. Antonsen, IEEE-TPS, **28** 1135-1143 (2000).

Self-modulation seeding:

Needed for injection of the e^- to be accelerated

Short ($\langle \lambda_{pe} \sim 1.5 \text{mm} \rangle$), co-propagating ionizing laser

- Minimum time evolution of the plasma density
- Best all together

Note: other seeding options were considered

- Cut beam
- Preceding short laser pulse
- Preceding short e^- bunch (seed hosing)

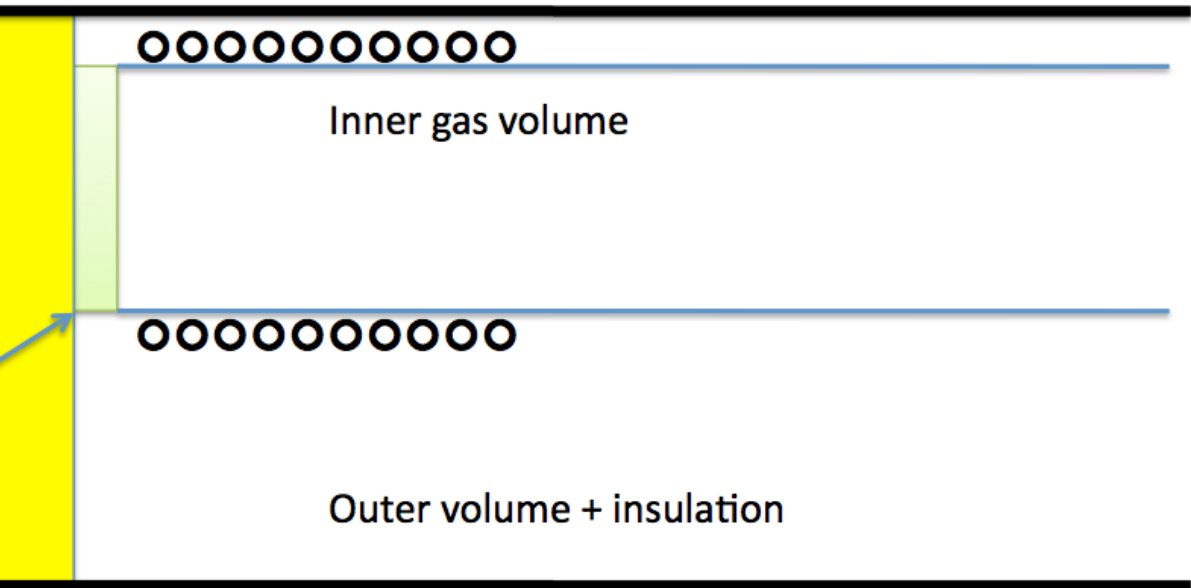
Determine plasma radius (laser pulse energy $\sim r^2$)

Take into account vapor index of refraction (Li $\lambda=633 \text{nm}$)

Laser wavelength?

Avoid inner e^- ionization

Front of Cell



Density uniformity requirements: 0.1%!!!

Solution:?

Metal vapor (no liquid/vapor interface, very

Laser pulse field ionization (threshold process)

SMI seeding by ionization front inside the p

Options:

Fast valves

Buffer gas to slow expansion/rarefaction, c

Larger volume near the ends

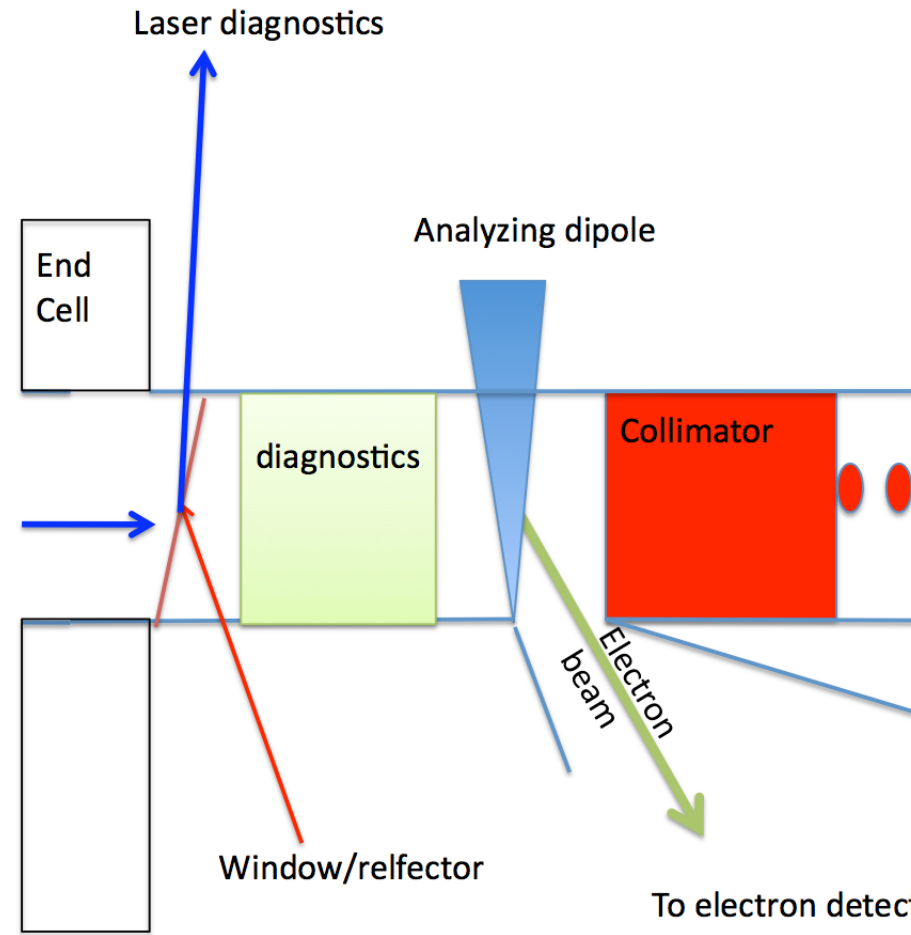
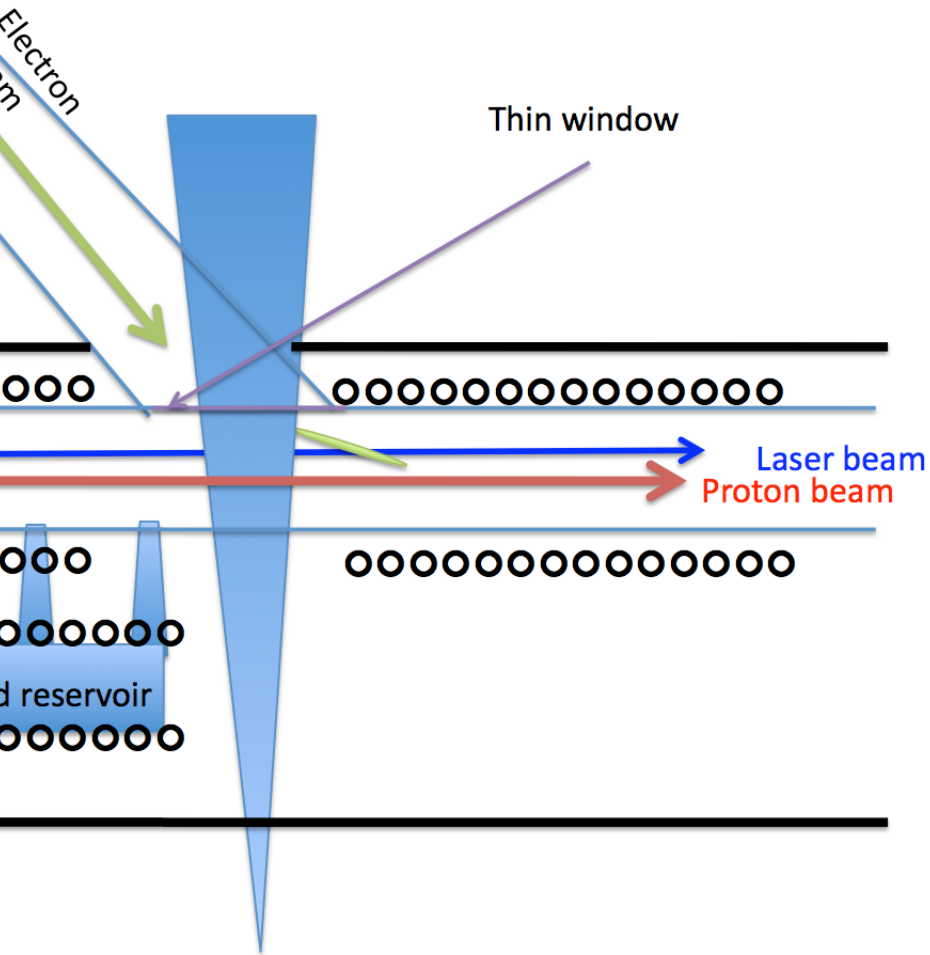
Issues:

Valve operation at high temperature (~250

Valves opening time (as short as possible)

Pressure/shock wave

e⁻ injection



Beam diagnostics:

Optical transition radiation (OTR) + fs stre

Electro-optic sampling (O. Reiman, R. Tarl

Photon acceleration

Proposed solution (V. Yakimenko)

Need to include:

Quadrupole doublet $\sim 0.75\text{m}$ long

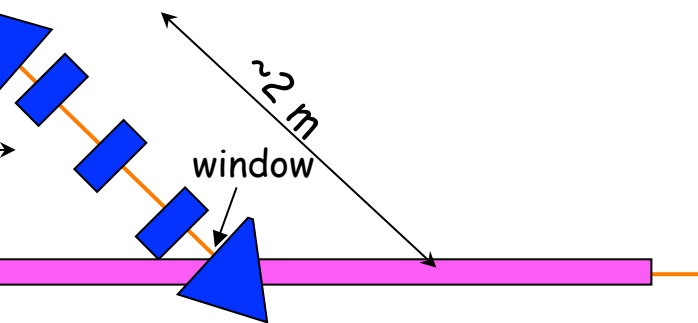
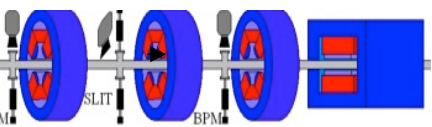
Quadrupole doublet $\sim 1.75\text{m}$

$\sim 1.5\text{m}$ offset

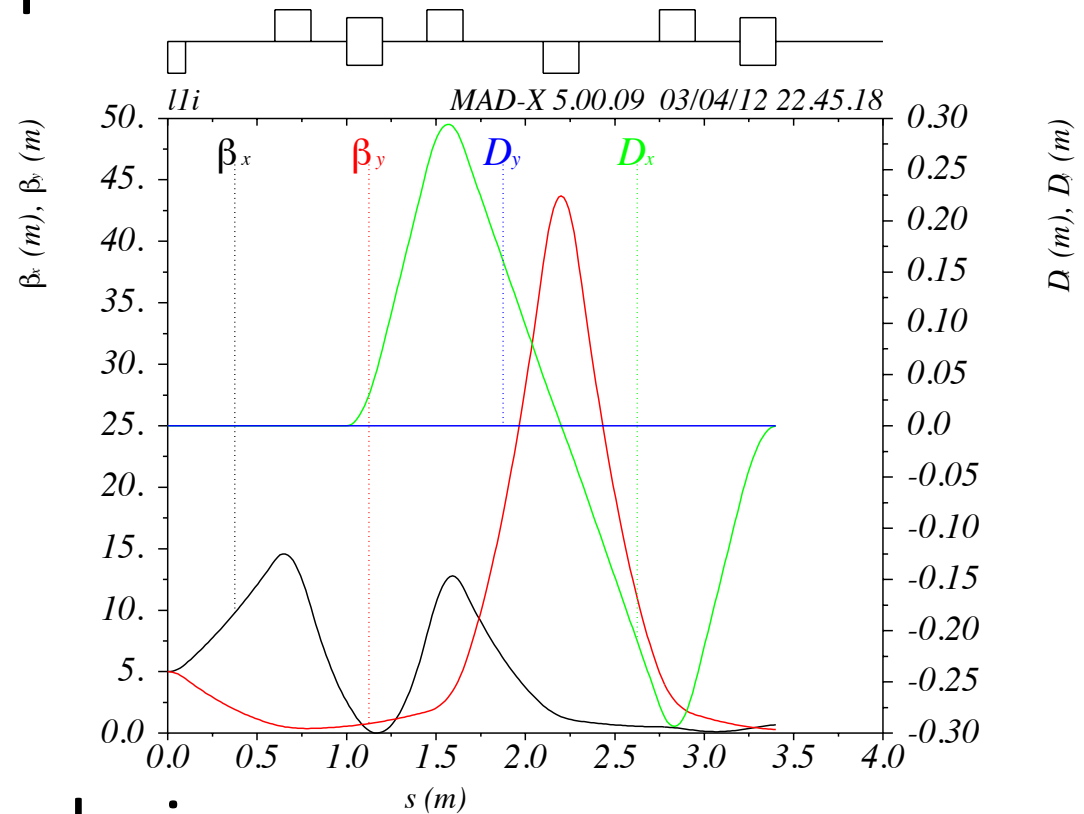
Up to 300G/cm (trivial, air cooled)

100G , $R \sim 13\text{cm}$, 20 cm long. Not trivial

Powered by a single 20 MW klystron

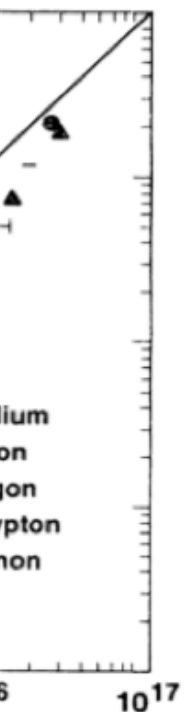


Optical function from linac exit



Conclusion

- Scattering in the window located 20 cm from the injection point will lead to $\sim 3\text{mrad}$ angular spread (RMS) (nice Gaussian distribution).
- Non trivial/custom injection dipole. (design depends on the plasma cell)
- Window need to be investigated: $1\text{mm} \times 0.5\text{ mm} \times 2\text{microns}$ was used at room temperature!
- Window can be installed at the entrance of the first dipole and collimate the beam size at the injection point at the cost of intensity. (difficult for e-)



etermined and
sing a simple
ct agreement.

Parameter	30 fs, 800nm	1 ps, 1057 nm
ϕ_{ioniz} [eV]	4.177	*
I_{ioniz} [Wcm^{-2}]	1.67×10^{12}	*
σ_{rb0} [μm]	200	*
$N_{\sigma_{rb0}}$	4	*
$N_{\sigma_{r10}}$	$1/\sqrt{2}$	*
σ_{r10} [μm]	1273	*
z_R [m]	6.37	4.81
z_{ioniz} [m]	6.78	5.13
I_0 [Wcm^{-2}]	2.14×10^{12}	*
L_p [m]	5	*
$V_{ionized}$ [cm^{-3}]	0.054	0.055
n_e [cm^{-3}]	6×10^{14}	*
E_{ioniz} [mJ]	21.5	22.3
E_{I_0} [mJ]	0.26	8.6
$E_{tot} = E_{ioniz} + E_{I_0}$ [mJ]	21.7	30.8
P_{ioniz} [TW]	0.73	0.031

Table 1: Parameters for the ionization of a rubidium vapor for two laser pulse lengths and wavelengths. The *s indicate the same value in both cases.

Parameter	30 fs, 800nm
ϕ_{ioniz} [eV]	5.392
I_{ioniz} [Wcm^{-2}]	4.63×10^{12}
σ_{rb0} [μm]	200
$N_{\sigma_{rb0}}$	4
$N_{\sigma_{r10}}$	$1/\sqrt{2}$
σ_{r10} [μm]	1273
z_R [m]	6.37
z_{ioniz} [m]	6.78
I_0 [Wcm^{-2}]	5.95×10^{11}
L_p [m]	5
$V_{ionized}$ [cm^{-3}]	0.054
n_e [cm^{-3}]	6×10^{14}
E_{ioniz} [mJ]	27.7
E_{I_0} [mJ]	0.71
$E_{tot} = E_{ioniz} + E_{I_0}$ [mJ]	28.4
P_{ioniz} [TW]	0.95

Table 2: Parameters for the ionization of a lithium vapor for two laser pulse lengths and wavelengths. The *s indicate the same value in both cases.

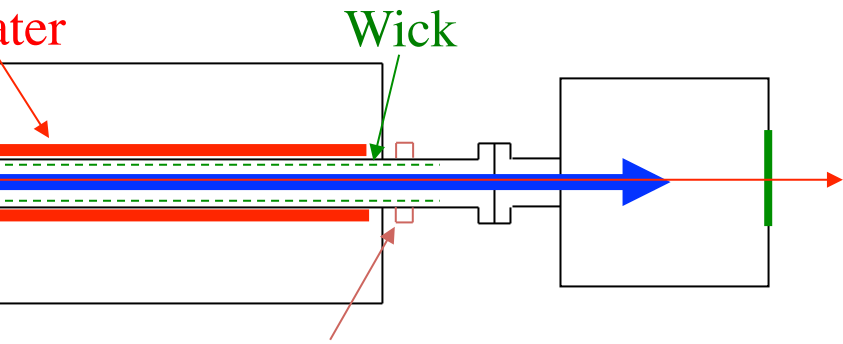
$$E_{ioniz} \propto \sigma_{r10}^2 \quad \text{Need to determine required plasma radius ...!!!!}$$

Options:

Ti:sapphire laser, more difficult to operate, maintain, but more versatile

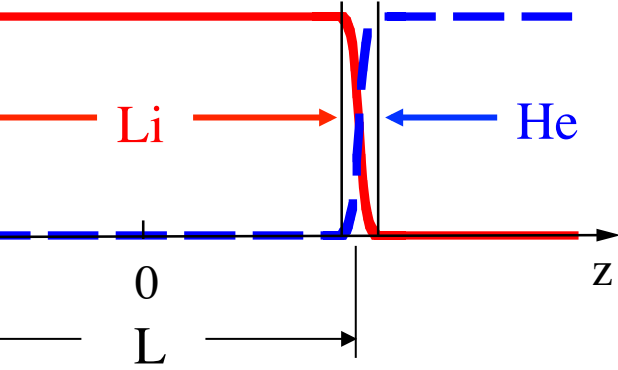
Fiber laser (~100fs), turn key, no maintenance, but less versatile

"SMA SOURCE"



Cooling Jackets

Boundary Layers



$n_0 = 2-4 \times 10^{15} \text{ cm}^{-3}$
 $T = 700^\circ\text{C}$
 $L = 1.4 \text{ m}$
 $P_{He} \approx 300 \text{ mT}$

$4 \text{ eV} < h\nu_{laser} = 6.5 \text{ eV} (\lambda = 1.93 \text{ nm})$

$\tau = 12 \mu\text{s}$

PS (1999)

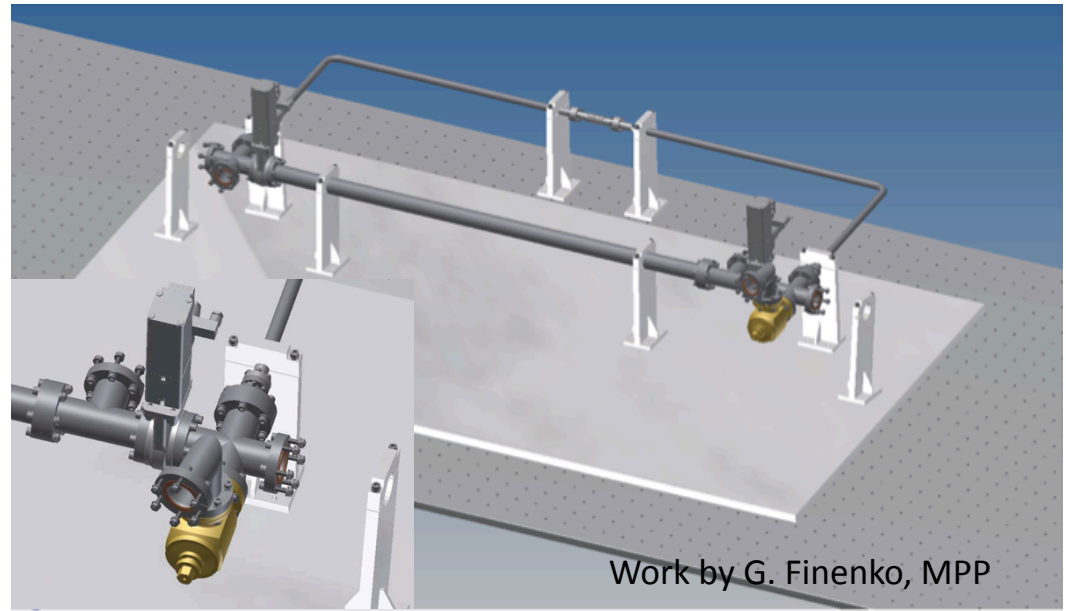
(at $n_e \approx 10^{14} \text{ cm}^{-3}$)

Choices:

Lithium: $IP = 5.45 \text{ eV}$, $T_{\text{melt}} \sim 184^\circ\text{C}$, $T \sim 500-600^\circ\text{C}$, $Z = 3$, $A = 7$, light

Rubidium: $IP = 4.18 \text{ eV}$, $T_{\text{melt}} \sim 39^\circ\text{C}$, $T \sim 130-200^\circ\text{C}$, $Z = 37$, $A = 85$

Cesium: $IP = 3.89 \text{ eV}$, $T_{\text{melt}} \sim 28.5^\circ\text{C}$, $T \sim 130-200^\circ\text{C}$, $Z = 55$, $A = 133$,
 (needs refrigeration)



$n_0 \text{ (cm}^{-3}\text{)}$

10^{15}

10^{16}

10^{17}

10^{18}

10^{19}

10^{20}

10^{21}



No

Loc

ISSUES & OPEN ISSUES

Learning from this initial design concept:

Is it needed for the sub-ps scale laser? (Patrick has a note - see his note).

Can beamline dipoles? Will the laser pulse pass

through the valves at the front of the plasma cell? (Vi-

vacuum windows at the rear of the plasma cell? (Er-

rectangular or horizontal? (discuss with Brennan God-

son before the dump or will this cause too much

scattering?

Feasibility of the plasma cells having only one pulse
per bunch?

Can we have monitors?

Can we have perturbations which throw off alignment,

density variation with time, ...

Major issues so far:

- Choice of beam line (TT61-CNGS)
- Design of the metal vapor source
 - Choice of metal (Li, Rb)
 - Front/end, valves, vapor uniformity
 - Ionization: laser propagation stability, laser parameters
- e^- beam injection